TITLE: METHOD FOR MANUFACTURING POLYCRYSTALLINE SILICON ...

INVENTORS: PARK, Ji Yong et al. SERIAL NO.: TO BE ASSIGNED DOCKET NO.: 1514.1032

## FIG.1A

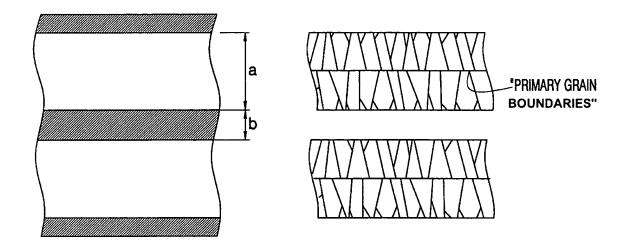
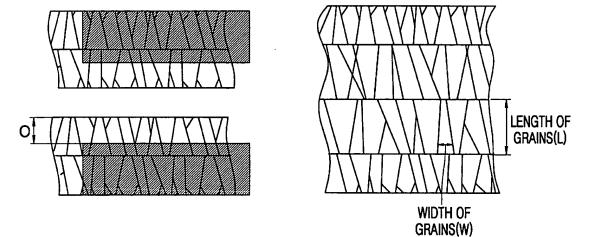


FIG.1B



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## FIG.2A

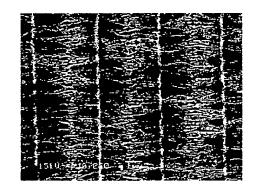


FIG.2B

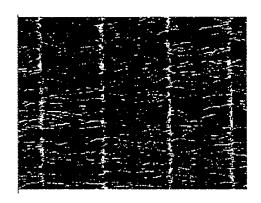
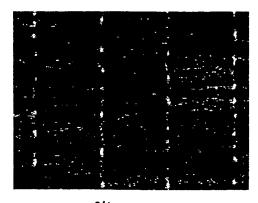


FIG.2C



FIG.2D



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FIG.3

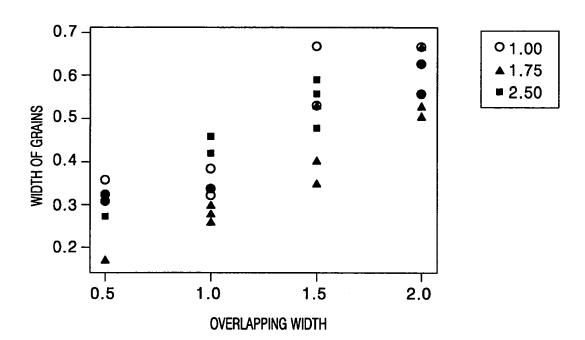
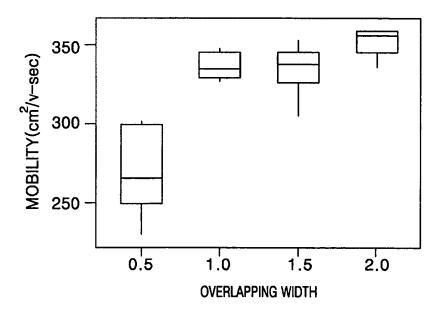


FIG.4



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FIG. 5

